Supporting Information for

## Flexible Waterproof Piezoresistive Pressure Sensors with Wide

## Linear Working Range Based on Conductive Fabrics

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## **Supplementary Figures**

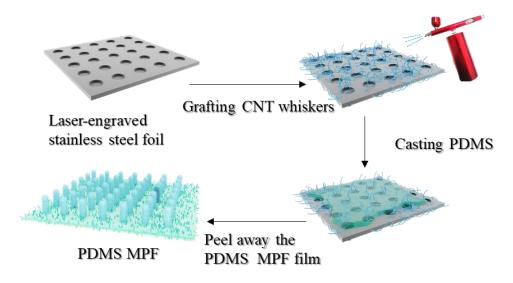
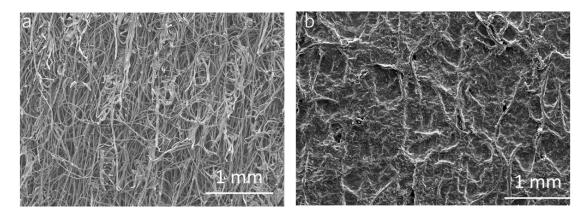


Fig. S1 Experimental process for preparation of PDMS micro pillar film (MPF)



**Fig. S2** Scanning electron microscope (SEM) of a non-woven fabrics (nWF) and b Graphite flakes (GFs) coated nWF

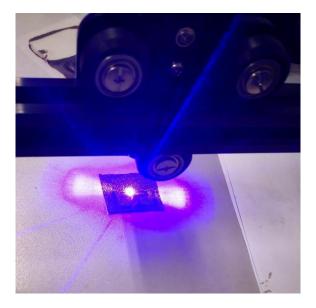
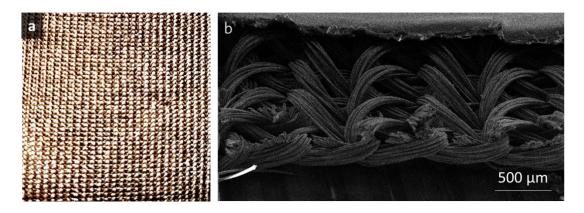


Fig. S3 SF was engraved by the laser



**Fig. S4 a** Digital optical images of Silver fabrics (SF) on the top view and **b** Side view SEM image of the SF

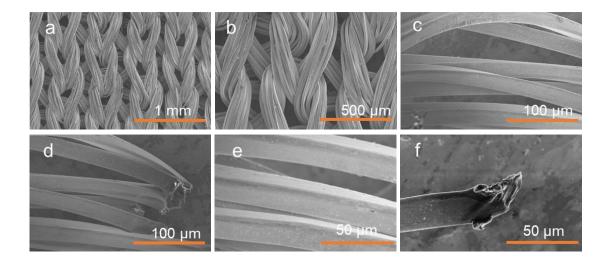


Fig. S5 SEM image of the SF and corresponding silver threads

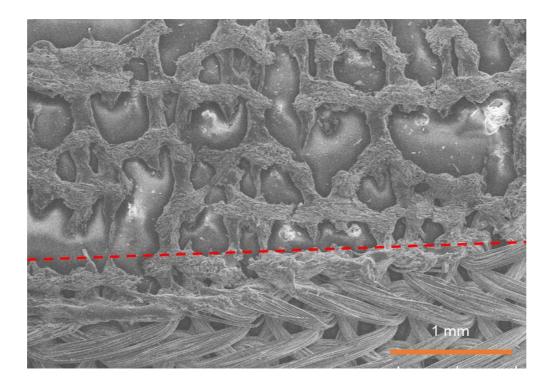


Fig. S6 Optical image and microscopes of the SF

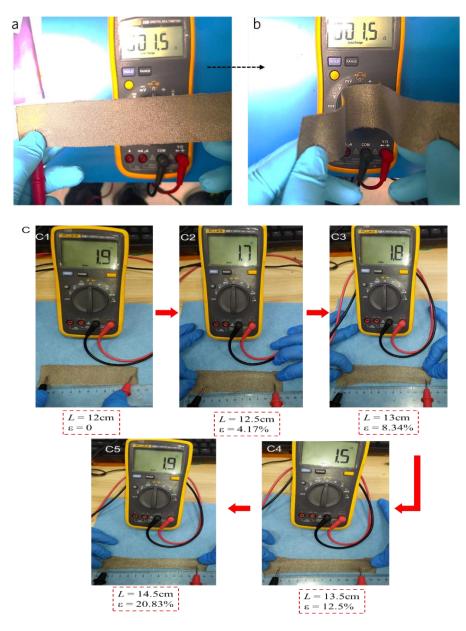


Fig. S7 Resistance of the SF electrode at (a) Flat, (b) bending, and (c) stretching status

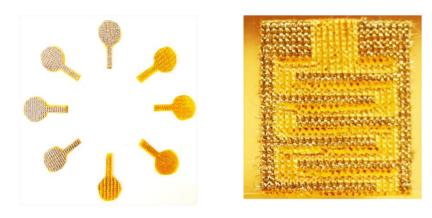


Fig. S8 Various patterns were fabricated by the laser

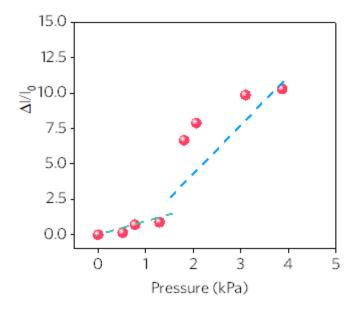


Fig. S9 Current variation at low pressure range

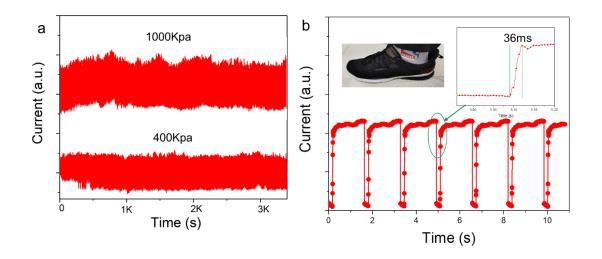


Fig. S10 a Durability test of the sensor under two higher applied pressure of 400 kPa

and 1000kpa for 3500s, respectively; **b** practical response time of our sensor under the plantar pressure from one adult male co-author (weight: 75kg)

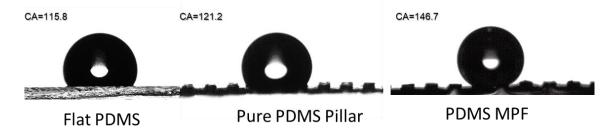


Fig. S11 Water contact angle of various substrate \$55/\$7

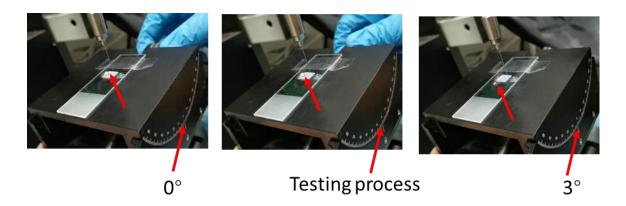


Fig. S12 Roll-off angle testing of water droplet

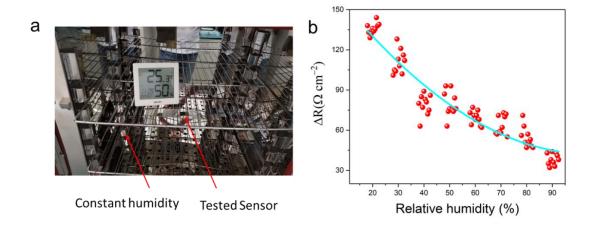


Fig. S13 a testing schematic of the sensor in the constant humidity cabinet; b Sensor resistance changes versus different relative humidity

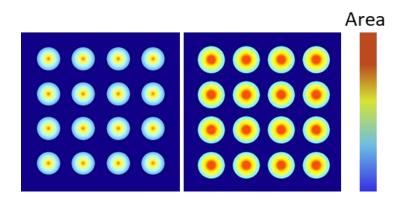
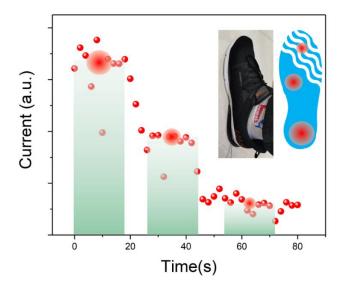


Fig. S14 Contacting area greatly increased with the applied pressure



**Fig. S15** Practical investigation of our sensor under the plantar higher pressure (over 400 kpa) from one adult male co-author (weight: 75kg)

## **Supplementary Movies**

Movie S1 Water was rapidly removed by the PDMS MPF

Movie S2 Bouncing of the water droplet with 16 times slower

**Movie S3** *in situ* transmission electron microscopy (TEM) nano-mechanical test of the graphite flakes (GFs) with 4 times faster

**Movie S4** Wearable sensor was able to detect the pulse rate and wirelessly send it to the smart phone

Movie S5 Flexible sensor can catch the gentle touch signal